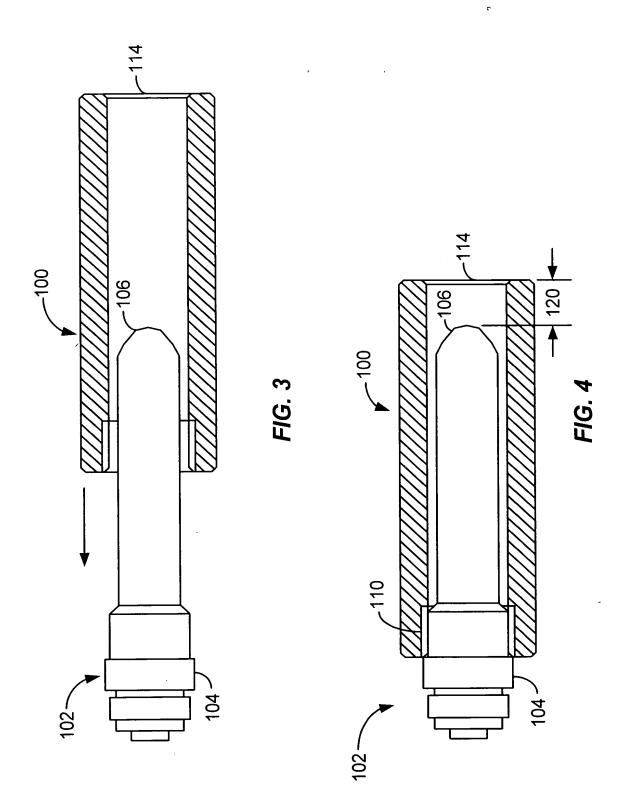
Chun-Pok Leung. No. 41,405, (650) 326-2400 Attorney Docket No.: A7728/T48810 Title: Gas Delivery System for Semiconductor Processing Applicant: Sudhir Gondhalekar et al.
Application No. 10/630,989 RH I 3 DIN H 1/4 34B 35A' 35B 35B' 35C 35D 35E 35D 35A 387 80B 43B |32C -52 25 728 16 1362 48 စ် 55 51 20-7 65 61

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Application No. 10/630,989 2/5 34C 34D .34B SiH o SiH 35D' 35A' 35B, 35B' 35C<sub>1</sub> 35D TO CLEANING SYSTEM 38A > TO TOP NOZZLE  $\left\{ \begin{array}{ll} -. \\ -. \end{array} \right.$ 40 ~ 39 37.

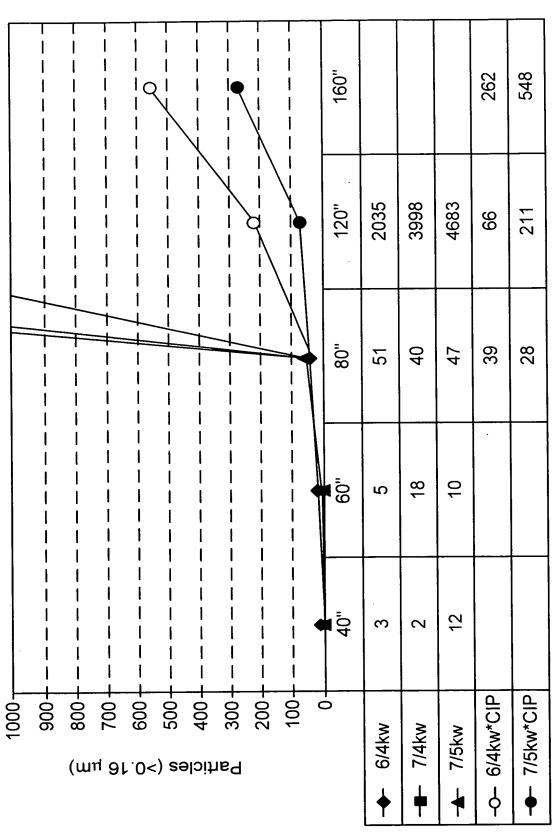
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